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SERIAL NUMBER 10/529,861	FILING OR 371(c) DATE 03/31/2005 RULE	CLASS 205	GROUP ART UNIT 1742	ATTORNEY DOCKET NO. HOK-0270
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APPLICANTS

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** CONTINUING DATA *****

This application is a 371 of PCT/JP04/07598 05/26/2004

** FOREIGN APPLICATIONS *****

JAPAN 2003-149961 05/27/2003
 JAPAN 2003-330351 09/22/2003

Foreign Priority claimed	<input type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY JAPAN	SHEETS DRAWING 14	TOTAL CLAIMS 28	INDEPENDENT CLAIMS 3
35 USC 119 (a-d) conditions met	<input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged	Examiner's Signature	Initials			

ADDRESS

23353

TITLE

Plasma processing apparatus, method for producing reaction vessel for plasma generation, and plasma processing method

FILING FEE RECEIVED 1300	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
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